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Docket: 0756-775

#11/PnC
1-19-93
D. Brooks

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GROUP 110

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Takashi INUSHIMA et al.)
Serial No. 07/971,242)
Filed: September 8, 1992)
For: CVD APPARATUS)

Art Unit No. 1104

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on 12-21-92.

Deborah T. Tomme

Deborah T. Tomme

PRELIMINARY AMENDMENT

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

Please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 1-6.

Please amend claims 7 and 8 as follows:

C1 7. (Amended) A method for forming a film on a substrate comprising the steps of: